

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:)
Hiroyuki NITTA, et al.) Group Art No. TBA
Serial No.: TBA) Examiner: TBA
Filed: June 19, 2001) Docket No: 01701.00086

J1036 U.S. PRO
09/083210  06/19/01

For: SEMICONDUCTOR DEVICE HAVING A WIRING LAYER OF DAMASCENE STRUCTURE AND METHOD FOR MANUFACTURING THE SAME

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Pursuant to 37 C.F.R. §1.56 and in compliance with 37 C.F.R. §1.97, Applicants submit herewith Form PTO-1449, identifying information for consideration by the Examiner. A copy of the item of information is enclosed.

Applicants do not waive any rights to take appropriate action to establish patentability over the listed document should it be applied as a reference against the claims of the present application.

Consideration of the cited information and making the same of record in the prosecution of the above-noted application are respectfully requested. Should the Patent and Trademark Office determine that a fee is required, please charge our Deposit Account No. 19-0733.

Respectfully submitted,

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